



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroto HORIKAWA

Group Art Unit: 2882

Application No.: 10/589,679

Examiner: M. ASFAW

Filed: August 16, 2006

Docket No.: 129109

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE FABRICATING METHOD

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 27, 2009 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, reconsideration of the rejection is respectfully requested in light of the following remarks.